

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Ted Liang

Application No.: 10/723,726

Filed: November 26, 2003

For: A Method to Locally Protect Extreme
Ultraviolet Multilayer Blanks Used for
Lithography

Examiner: Vetere, Robert A.

Art Unit: 1792

Confirmation No.: 9790

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR §1.111

Dear Examiner:

This is in response to the Office Action mailed April 30, 2008. Applicants respectfully request the Examiner to enter this Amendment and consider the following remarks.

The Listing of Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

I hereby certify that this correspondence is being deposited via
EFS Web on the date below:

July 30, 2008

Date of Deposit

/Justin K. Brask/

Justin K. Brask, Reg. #61,080